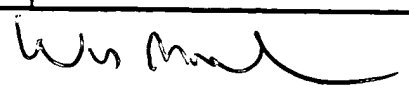


FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Docket Number (Optional) 608.0017USX		Application Number Not Yet Assigned	
Applicant Vitt et al.				Filing Date Herewith		Group Art Unit Not Yet Assigned	
U. S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
WA	3,781,090	12/73	Sumita	—	—		
	3,829,197	8/74	Thelen	—	—		
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WA	6,379,803	4/02	Nakamura et al.	—	—		
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
WA	EP0727813	8/21/96	Europe	—	—		
WA	JP05341121	12/24/93	Japan	—	—		
WA	JP05341122	12/24/93	Japan	—	—		
WA	DE4326947	4/20/95	Germany	—	—		
WA	WO/0027771	5/18/00	PCT	—	—		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
"Properties and applications of oxide layers deposited on glass from organic solutions" Schroeder, October 20, 1961, Jenaer Glaswerk Schott & Gen., Mainz, Germany							
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EXAMINER 				DATE CONSIDERED 2/22/05			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through Citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							

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Sheet 2 of 2

FORM PTO-1449

INFORMATION DISCLOSURE CITATION
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Docket Number (Optional)

608.0017USX

Application Number

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
WA	DE 3300589 C2	9/22/88	Germany	—	—		
WA	DE 4326947	4/20/95	Germany	—	—		
WA	0 438 646 B1	11/7/90	Europe	—	—		
WA	0 300 579 A2	7/15/88	Europe	—	—		

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"Dünne Schichten auf Glas," Von Walter Geffcken, Glastechnische Berichte, June 1951, p. 143-151.

EXAMINER

WA [Signature]

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2/22/05

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FORM PTO-1449

Application Number

10/775,010

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Group Art Unit

February 9, 2004

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U. S. PATENT DOCUMENTS

[illegible]

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

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WA	Article titled "Design of Coatings for Wide Angular Range Applications", Tikhonravov, et al., SPIE Vol. 3133, 1997, pps. 16-24
WA	Article titled "Application of the Needle Optimization Technique to the Design of Optical Coatings", Tikhonravov, et al., Applied Optics, 1 October 1996, Vol. 35, No. 28, pps. 5493-5508
	European Search Report, Appln. No. 00 985 184.1, dated February 2, 2004

EXAMINER

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